1 (APIB) (IS) anim	-20 - 2001 HEET U.S. DEPARTMENT OF COMMERC Patent and Trademark Office
To the Honorable Commissioner of Pate	1816614 hed original documents or copy thereof.
1 Name of conveying party(ies):	2 Name and address of receiving party(ies):
Lu-Chang Chen	Taiwan Semiconductor Manufacturing Co. Ltd. No. 121 Park Avenue 3 Science-Based Industrial Park Hsin-Chu, Taiwan, R.O.C.
3 Nature of conveyance: ■ Assignment	Additional name(s) & address(es) attached □ Yes ⊠ No
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4 Application number(s) or patent number(s):	
If this document is being filed together with a new app	plication, the execution date of the application is: <u>06-06-01</u>
A. Patent Application No(s).	B. Patent No(s)
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5 Name and address of party to whom correspondence concerning document should be mailed:	6 Total number of applications and patents involved:
RANDY W. TUNG Tung & Associates 838 W. Long Lake Road	7 Total fee (37 CFR 3.41) \$40.00
Suite 120 Bloomfield Hills, Michigan 48302	⊠ Enclosed
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To the best of my knowledge and belief, the foregoing the original document.	n information is true and correct and any attached copy is a true copy of
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ail documents to be recorded with required cover sheet information to Commissioner of Patents & Trademarks, Box Assignments Washington, D.C. 20231

67,200-488

PATENT REEL: 012073 FRAME: 0473

ASSIGNMENT

WHEREAS, I, <u>LU-CHANG CHEN</u> have invented certain improvements in METHOD AND APPARATUS FOR AVOIDING DRIVER GAS

CONTAMINATION IN AN ION IMPLANTER GAS SUPPLY MODULE

for which I am about to make application for Letters Patent of the United States; and

WHEREAS, TAIWAN SEMICONDUCTOR MANUFACTURING CO., LTD. of No. 121, Park Avenue 3, Science-Based Industrial Park, Hsin-Chu, Taiwan, R.O.C, is desirous of

acquiring the entire right, title and interest in and to said invention;

1

PATENT REEL: 012073 FRAME: 0474

I further authorize said corporation to apply for foreign patents on said invention in its own name or through its designees, including subsidiaries, related companies or assignees, under the International Convention or otherwise, and I further agree to execute all papers, including those required for the United States and foreign applications, and to perform such other proper acts as said corporation or its designees the rights herein assigned.

Lu-Chang Chen Lu-CHANG CHEN

TUNG & ASSOCIATES 838 W. Long Lake Road **Suite 120** Bloomfield Hills, Michigan 48302

RECORDED: 08/10/2001

2

PATENT REEL: 012073 FRAME: 0475